

Substitute for Form 1449/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				Application Number	10/603,379
				Filing Date	June 24, 2003
				First Named Inventor:	Nicolaescu et al.
				Art Unit	2874
				Examiner Name	Not Yet Assigned
Sheet	1	of	1	Attorney Docket Number	

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				
16	4	WO 00/72064 A1	11/30/2000	NANOVATION TECHNOLOGIES, INC.		

Examiner Signature		Date Considered	2/21/05
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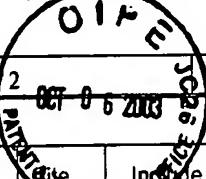
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Sheet

2

of

2

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Application Number	10/603,379
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First Named Inventor:	Remus Nicolaescu et al.
Art Unit	Not Yet Assigned
Examiner Name	Not Yet Assigned

42P14248X

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Date No.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
10	5.	Soref, R.A., et al., "Vertically Integrated Silicon-on-Insulator Waveguides," IEEE Photonics Technology Letters, Vol. 3, No.1, January 1991, pp. 22-24	
10	6.	Bachmann, M., et al., "General Self-Imaging Properties In NxN Multimode Interference Couplers Including Phase Relations," Applied Optics, Vol. 33, No. 18, June 20, 1994, pp. 3905-3911	
10	7.	Soldano, L.B., et al., "Optical Multi-Mode Interference Devices Based on Self-Imaging: Principles and Applications," Journal of Lightwave Technology, Vol. 13, No. 4, April 1995, pp. 615-627	
10	8.	Rasmussen, T., et al, "Design and Performance Evaluation of 1-by-64 Multimode Interference Power Splitter for Optical Communications," Journal of Lightwave Technology, Vol. 13, No. 10, October 1995, pp. 2069-2074	
10	9.	Muttukrishnan, R. et al., "Accurate Analysis of MMI Devices with Two-Dimensional Confinement," Journal of Lightwave Technology, Vol. 14, No. 9, September 1996, pp. 2078-2084	
10	10.	Smit, M.K., et al., "Phasar-Based WDM-Devices: Principles, Design and Applications," IEEE Journal of Selected Topics In Quantum Electronics, Vol. 2, No. 2, June 1996, pp. 236-250	
10	11.	Karrenahalli, S., et al., "Experimental Confirmation of Phase Relationships of Multimode Interference Splitters Using a Shearing-Type Near-Field Sagnac Interferometer," IEEE Photonics Technology Letters, July 1997, pp. 937-939	
10	12.	Lorenzo, R.M., et al., "Improved Self-Imaging Characteristics in 1xN Multimode Couplers," IEE Proc.-Optoelectron, Vol. 145, No. 1, February 1998, pp. 65-69	

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